



RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2876

00862.022319

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ken MATSUMOTO

Application No.: 09/920,752

Filed: August 3, 2001

For: SUBSTRATE TRANSFER APPARATUS,  
SEMICONDUCTOR MANUFACTURING  
APPARATUS, AND SEMICONDUCTOR  
DEVICE MANUFACTURING METHOD

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: Examiner: L. M. Caputo  
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: Group Art Unit: 2876  
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: Confirmation No.: 5950  
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) April 10, 2006  
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4/20/06  
amr*

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Official Action dated January 10, 2006, please amend the above-identified application as follows, pursuant to 37 CFR 1.116:

*OK to enter the 4/14/06*